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Class	SSUE CLA

U.S. UTILITY Patent Application

M/ O.I.P.E.

PATENT DATE

50.400

SCANNED Y Q.A.

ART UNIT EXAMINER

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Method for annealing ultra-thin, high quality gate oxide layers using oxidizer/hydrogen mixtures

PTO-2040

(Attached in pocket on right inside flap)

ORIGINAL CROSS REFERENCE(S)

CLASS SUBCLASS CLASS SUBCLASS (ONE SUBCLASS PER BLOCK)

INTERNATIONAL CLASSIFICATION

INTERNATIONAL CLASSIFICATION

Continued on Issue Slip Inside File Jacket

Sheets Drwg.		DRAWINGS		CLAIMS ALLOWED	
	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.	
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	(Primary E	(Primary Examiner) (Legal Instruments Examiner)	(Primary Examiner) (Date) (Legal Instruments Examiner) (Date)	(Assistant Examiner) (Date) ISSUE Amount Due (Primary Examiner) (Date) ISSUE BAT (Legal Instruments Examiner) (Oate) stricted. Unauthorized disclosure may be prohibited by the United States Code Title 35 mark Office is restricted to authorized employees and contractors only.	

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